Electronic Acknowledgement Receipt		
EFS ID:	3900555	
Application Number:	10690507	
International Application Number:		
Confirmation Number:	6043	
Title of Invention:	Method for manufacturing polycrystalline silicon thin film and thin film transistor fabricated using polycrystalline silicon thin film manufactured by the manufacturing	
First Named Inventor/Applicant Name:	Ji Yong Park	
Customer Number:	49455	
Filer:	Hung H. Bui/Karen Jones	
Filer Authorized By:	Hung H. Bui	
Attorney Docket Number:	1514.1032	
Receipt Date:	08-SEP-2008	
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Application Type:	Utility under 35 USC 111(a)	

Payment information:

Submitted with Payment	no	

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
1		AmendFiled-09-08-2008.pdf	1681758	ves	15
	7. Inches inches 55 55 2555	America ace os co zoos.par	6310ebcd4e780828766c336541131d24be 3d0c5d	/	. ,

Multipart Description/PDF files in .:	zip description	
Document Description	Start	End
Fee Worksheet (PTO-06)	1	1
Amendment - After Non-Final Rejection	2	2
Claims	3	5
Applicant Arguments/Remarks Made in an Amendment	6	15

Warnings:

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DD/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the filling Receipt. In due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.